Docket No.: 0756-2077 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

Śhunpei YAMAZAKI, et al

Serial No. 09/466.828

Filed: 12/20/99

) Examiner: Renee R. Berry

For: INSULATING FILM AND METHOD OF PRODUCING SEMICONDUCTOR DEVICE

## REQUEST FOR ACKNOWLEDGMENT OF

## INFORMATION DISCLOSURE STATEMENT

CERTIFICATE OF MAILING

) Group Art Unit:

Assistant Commissioner for Patents P. O. Box 1450 Alexandria VA 22313-1450

Sir:

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on July 17, 2003

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Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee Due form mailed July 2, 2003 acknowledging the filing of an Information Disclosure Statement on March 3, 2003.

The Notice of Allowability did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statements filed May 10, 2002 and April 2, 2003. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the IDS of May 10, 2002 and April 2, 2003 by providing a copy of the initialed Form PTO-1449.

If a conference would beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference. (ECHNOLOGY: CENTER 2800

Respectfully submitted.

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